



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Zhiyi YU, et al.

SERIAL NO: 09/842,734

GAU: 2811

FILED: April 26, 2001

EXAMINER: HU, SHOUXIANG

FOR: STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND  
DEVICES USING BINARY METAL OXIDE LAYERS

**REQUEST FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

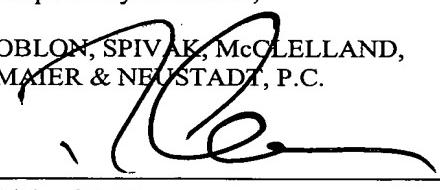
It is hereby requested that a **ONE MONTH** extension of time be granted to **NOVEMBER 5, 2005** for

- filing a response to the Official Action dated:
- responding to the requirements in the Notice of Allowability dated:
- filing the Formal Drawings. The Issue Fee due      has been timely filed.
- responding to the Notice to File Missing Parts of Application dated:
- filing a Notice of Appeal. A timely response to the final rejection has been filed.
- A Request for Continued Examination is concurrently being filed herewith.**
- Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$120.00 is enclosed herewith by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

  
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